


IDS - 10/13/2005 ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	METHOD AND SYSTEM FOR DYNAMIC MODELING AND RECIPE OPTIMIZATION OF SEMICONDUCTOR ETCH PROCESSES						
Application Number :	10/523777						
Confirmation Number:	5732						
First Named Applicant:	Kun Li						
Attorney Docket Number:	VOY007US						
Art Unit:	2825						
Examiner:							
Search string:	(6133132).pn						
US Patent Documents							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
SRG	1	6133132	2000-10-17	Toprac et al.			
Signature							
Examiner Name				Date			
/Steven Garland/				08/09/2006			